

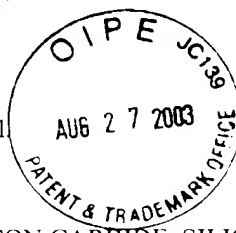
Docket No. 209291US0

IN RE APPLICATION OF: Hiroyuki NAGASAWA, et al

SERIAL NO: 09 867,467

FILED: May 31, 2001

FOR: METHOD OF MANUFACTURING SILICON CARBIDE, SILICON CARBIDE, COMPOSITE MATERIAL, AND SEMICONDUCTOR ELEMENT



COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

Corres. and Mail  
**BOX AF**

SIR:

Transmitted herewith is an Amendment under 37 CFR 1.116 in the above-identified application.

☒ No additional fee is required

☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

☐ Additional documents filed herewith:

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SEP 02 2003  
TC 1700

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	18	MINUS	20	0	x \$18 =	\$0.00
INDEPENDENT	3	MINUS	3	0	x \$84 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

☐ A check in the amount of \$0.00 is attached.

☐ Credit card payment form is attached to cover the fees in the amount of \$0.00

☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment form is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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Appln No. 09/867,467

Reply to the final Office Action of June 5, 2003



DOCKET NO.: 209291US0

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TC 1700

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:

:

Hiroyuki NAGASAWA et al

: GROUP: 1765

SERIAL NO.: 09/867,467

: EXAMINER: M. Song

FILED: May 31, 2001

:

FOR: METHOD OF MANUFACTURING SILICON CARBIDE,  
SILICON CARBIDE, COMPOSITE MATERIAL,  
AND SEMICONDUCTOR ELEMENT

**AMENDMENT UNDER 37 CFR 1.116**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VA. 222313

SIR:

Responsive to the Official Action dated June 5, 2003, please amend the above-identified application as follows.

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the claims** begin on page 7 of this paper.

**Remarks/comments** begin on page 11 of this paper.